Laser Inertial Fusion Dry-Wall Materials Exposure to X-rays and Ions*

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Outline of Presentation

- IFE Threat Spectra: RHEPP-1 and Z as simulators to ion/x-ray threat to first wall
- Brief Summary of Z exposure results tungsten
- Description of RHEPP-1 and and Heating/exposure Cycle
- Materials exposed on RHEPP-1 (ions):

W and W alloys Powder Metallurgy Tungsten (PM W) Single Crystal W Alloyed W - W25Re, W1%La

Graphite/Carbon Fiber Composites (CFCs):

'Engineered' Materials as an alternative to flat wall Carbon fiber 'Velvet W/Tac and W/HfC 'Foams'

Conclusions





Summary of Exposure Results

- Ion and X-ray exposure forms key part of Laser IFE Direct Drive First-Wall Threat. RHEPP-1 ion beams (multi-pulse)and Z x-rays (singlepulse) can simulate this threat with good fidelity
- Z results (X-rays on tungsten): melt threshold at 1.3 J/cm²; roughening threshold is grain-structure dependent, but < 1 J/cm²

RHEPP Results:

- For W materials, most serious issues are 1) Roughening below melt, evidently caused by thermomechanical stress, and 2) Stress cracking. Stress cracks deepen with pulse number, and may reach deep into interior. This is true regardless of melt. 'Divit' formation may indicate outright mass loss. Lower limit forPM W roughening is low ~ 1 J/cm².
- For Graphite/Carbon Composites (CFCs), good survivability at low fluence, but rapid loss above sublimation. Physical sputtering or radiation-induced sublimation?
- Engineered materials such as 'Velvet' or 'Foam' are up-optimized so far, but may be an alternative surface design



These results are also relevant to MFE W exposure due to Type I EL





Laser IFE Direct Drive Threat Spectra



Simulation: Thermal Power to Wall in Ions from 154 MJ Yield. Wall Radius: 6.5 m

- For Direct-drive Laser IFE: 1-2% x-rays 30% ions (50-50 fusion and 'debris) ~70% neutrons
- Ions: several MeV, ~ 0.5 µsec each, 8-20 J/cm² fluence, judged Significant Threat
- X-rays: ~ 1 J/cm², up to 10 keV energies, judged less significant threat
- Z: up to 10 keV x-rays, good single-shot simulator
- RHEPP-1: 800 keV He, higher for N⁺², 100-300 ns pulsewidth
- RHEPP-1 energy delivery too short, but otherwise good fidelity with reactor ion threat





Regimes of IFE Materials Response Studies for x-rays and ions





T IR 04/16/2004



Z Results - PM W Melting/Roughening Thresholds

Tungsten Exposure on Z: Melting and Roughening Thresholds

- Tungsten samples exposed to various fluence levels in Z machine with single shots.
 - Varied source-to-sample distance
 - Filter material: $8\mu m$ Be and $2\mu m$ Mylar
- Polished tungsten (Snead) prepared in 3 different ways:
 - single crystal
 - rolled powdered metal
 - chemical vapor deposition
- Latest samples preheated to 600° C
- Surfaces analyzed with
 - optical surface profilometer
 - Scanning electron microscope (with backscatter detector)
 - focused ion beam







Z Results - PM W Melting Thresholds

Single-pulse Z data shows no melting below 1.3 J/cm²







1.3 J/cm² 2 m kimfoil 2.5 m Be 0.1 m Al No melting 2.3 J/cm² 2 m kimfoil 0.1 m Al 0.5 μ melting

19 J/cm² 2 μ melting

Unheated W
Difficult to assess roughening with Z samples







Melt depth vs. Fluence on Z



•Experimental points (error bars) and BUCKY calculation (squares) using filtered fluence numbers.

•For melt depths < 0.2 μ (dashed line), melt depth < crystal grain size, so may or may not result in observable effect





Z Results - PM W Roughening Thresholds

Images from samples on Z from VEECO surface profiler









Z Results - PM W Roughening Thresholds





Roughening threshold: ~0.9 J/cm² - single crystal, and ~<0.3 J/cm² for polycrystalline tungsten



Pulsed Power Sciences, Sandia National Laboratories

TJR 04/16/2004

RHEPP-1 combines Repetitive High Energy Pulse Power with a robust and versatile ion source: MAP



Left: Marx tank with pulse-forming line Right: 4-Stage LIVA and treatment chamber







The MAP (Magnetically Confined Anode Plasma) Ion Source is used for surface modification experiments on RHEPP-1





- < 250 A/cm²
- Beams from H, He, N₂, O₂, Ne, Ar, Xe, Kr, CH₄
- Overall treatment area ~ 100 cm²
- Diode vacuum
 ~ 10⁻⁵ Torr







Nitrogen injection into MAP produces 3-component beam of mostly N++, N+



- Beam predominantly N++ and N+ after small proton pulse at front
- Peak voltage = 850 kV
 Peak current density (total) ~145 A/cm²
- Total fluence = 7.9 J/cm² will ablate almost all materials
- Total pulse width ~ 200 ns
- Ion range (TRIM):
 N+ 0.9 μm, N++ 1.2 μm
- Oxygen, Neon beams similar







He beam (HE⁺¹) pulsewidth is longer than N or C beam



- He current lags voltage, leading to debunching
- Current pulse width at 63 cm is almost 0.5 µsec long
- Beam here was intentionally attentuated
- He range in W (TRIM) ~ 0.9 μm
- Range similar to N beam because singly charged



Thresholds for Materials exposure to ions on RHEPP





RHEPP-1 Surface Roughening

Range of Fluences, MaxTemps (W) for RHEPP-1







RHEPP-1 Ion Exposure

Setup for current 2000 pulse Series: Metals and graphite, RT and 520C Roughening and fatigue propagation study



- Goals: Test below-melt response, explore if roughening saturates, study crack propagation, 2000 pulses total
- Upper Photo: 6-element heated samples (right), RT samples (left). Heated samples below melting, RT below/above
- Heated samples: CFC NB31, PM W (Snead), W25Re, graphite R6650, Sing XtalW(Snead), WC. C samples from FZ Julich (Linke). Velvet added later
- Samples shot 400X, then SEM, Dektak (Renk/Tanaka), then reloaded for another 400 shots.
- RT samples: PM W, Sing Xtal W, NB31, R6650, Ti-6AI-4V, W25Re, Re

After 400 pulses





RHEPP-1 Surface Roughening

Surface Roughening: Develops over many pulses Increases with fluence/shot number; PM W the worst



- Roughening increases ~ linearly with pulse number
- Roughening increases with fluence per pulse
- Very little surface relief happens until after 200 pulses
- 4.5 J/cm² is between melt and ablation for W
- He beam roughens more than N (black points)
- CVD, SingXtal (actually, everything) roughens less than PM W
- W Peak-Valley exceeds 70 µm at 600 shots
- Is W roughening reaching saturation?







RHEPP-1 Surface Roughening

Evolution of R_a Roughness at 2.5 J/cm², various metals : PM W is worst, then everything else. Cu does NOT roughen



- 2.5 J/cm² is near or above melt for most metals shown
- Polished W and Mo are heated to 550-600C
- MO reaches 2 µm Ra at 1000 shots, but Cu remains very flat
- Ti-2, Mo roughen steadily to 1000 shots
- W Peak-Valley exceeds 35 µm at 600 shots, then plateaus. Is this a saturation point?







RHEPP-1 PM W Surface Roughening

R_a as function of Number of Nitrogen pulses @ 4.0 J/cm²: (Right) - Roughness increases from 200-400-600 pulses

I-D 8 mm Profilometer Scans, 450x He (Left) and Nitrogen (Right)



Left Side (He) same in ALL plots. Material: Snead PM W







RHEPP-1 PM W Surface Roughening

SEMs of PM W (non-melt): appears stress cracking starts, then exfoliation, forming valleys



All images 2000X



800 pulses

1600 pulses

- Heated PM W (600C) exposed to N beam at ~ 1.5 J/cm² - peak temp ~ 3300K
- Rounded 'knobs' are actually high points. But does average surface height rise or fall?





RHEPP-1 PM W Surface Roughening

PM Tungsten after 1600 pulses (non-melting): Mostly mountains



Tungsten 1600 Pulses

- Heated/treated PM W examined with NEXIV laser interferometry
- Comprehensive line-out scan: max height 30 μm, min height < 10 μm compared to untreated
- Very deep microcracking is present but not visible here





RHEPP-1 PM W Fatigue Cracking

FIB-XTEM of 1000-pulse W at 2.25 J/cm² (ave): Deep horizontal/vertical cracking without melt



- Polished Powder Met W exposed to 100 shots N beam @ 2.25 J/cm² ave /pulse, ~ melting temperature at surface. No melt layer observed.
 600°C exposure
- •Sample cracking horizontally/vertically down to 10 µm depth
- •Suspect fatigue-cracking





Fatigue Cracking only evident after extended exposure -XTEM of 60X-treated PM W (right) show no cracking in depth





Bright-Field TEM image

TEM image from 5 μm depth



60 pulses at ablation threshold: No cracks





RHEPP-1 Roughening Threshold, W, Multi-pulse

New 2000Series confirms multi-pulse roughening threshold for PM W at ~ 1 J/cm² (RT). R_a increases rapidly with fluence





RHEPP-1 Surface Roughening, Current Series

Evolution of R_a Roughness , current series plus previous data: PM W RT roughening severe, heating helps, but trend w/shots is up



- Red Dots shows roughening threshold for PM W unheated - ~ 1 J/cm²
- Every other metal < 1 μm Ra up to 1000 pulses (Re shown)
- Heated PM W Snead at 1.1 J/cm² very smooth except for Divits
- Heated Shwarzkopf PM W @ 2.5 J/cm² reaches Snead RT roughness at 1000 pulses

Note: Heated W, W25Re Ra does NOT include Divits





Current series, Optical Micrographs, surfaces after 400 pulses





RHEPP-1 Surface Roughening

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Heated W, W25Re, SingXtal smooth except for 'Divits'







Graphite Response: Rapid material removal above sublimation point, consistent with BUCKY predictions



- Mechanically polished pyrolitic graphite (PG), Poco, and 4D carbon composite weave exposed to 75 pulses/225 pulses of 70% C /30% H beam at doses of 1.9 to 5 J/cm²
- PG ablation threshold ~ 4 J/cm²
- Poco ablation threshold ~ 3 J/cm²
- Above threshold, rapid increase in ablated material per pulse with dose. Data scatter reflects uncertainty in dose
- Composite matrix ablates more than PG/Poco, fibers comparable (sample rough)







RHEPP-1 CFC Carbon Response

FMI-222 Fiber ends appear ablation-resistant; Matrix loss ~ 0.3 μm/pulse at 4.0 J/cm²:



'Foam' (Ultramet) exposure to ions: W/TaC suffers erosional loss, W/HfC brittle failure



Foam geometry, untreated, 50X



W/TaC, after 1200 pulses, 2500X

W/HfC, 800 pulses, 250X

All exposures between 1 - 1.5 J/cm²

Side view, W/TaC, after 800 pulses, showing EXPANDED height (left)

SEMs: Thinner structure, better Bonding may be necessary



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ESLI CCV/W Test Specimen

ESLI Carbon-Carbon Velvet (CCV) with sputtered-W Coating

Carbon fiber volume packing 1.9%

Sputtered-W film thickness 1.6 µm over area

Thick $(1.6 \ \mu m)$ caps on fiber tips; thin $(<0.1 \ \mu m)$ film on fiber shafts (thickest at top)

Design for RHEEP incidence angle (0.3-0.5 radian)

Fluence distribution

On flat fiber tops On fiber shafts On graphite substrate 100% of incident fluence< 25% of incident fluence (max near top)<5% of incident fluence





ESLI

HAPL Sep 2003 (Madision, WI)

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RHEPP-1 Carbon/W Velvet Response

W-coated Carbon 'Velvet' exposure to ions: 1.6 μ m W survives on sharp tips, 200 pulses at 6 J/cm²



1.6 µm W survives ablation-level Fluence on SOME tips





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